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Appl. No. 09/451,619

Amdt. Dated November 2, 2004

Reply to final Office Action of July 2, 2004

Attorney Docket No. 81788.0025

Customer No.: 26021



**AFTER FINAL RESPONSE UNDER 37 C.F.R. §1.116  
EXPEDITED PROCEDURE**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Seiichi Mori

Serial No: 09/451,619

Confirmation No.: 9292

Filed: November 30, 1999

For: NON-VOLATILE SEMICONDUCTOR  
MEMORY AND MANUFACTURING  
METHOD THEREOF

Art Unit: 2814

Examiner: Howard Weiss

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November 2, 2004

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Name

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11/02/04

Date

**AMENDMENT UNDER 37 C.F.R. § 1.116**

MAIL STOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the final Office Action dated July 2, 2004. The time for response to the outstanding final Office Action is extended one month by the accompanying petition from October 2, 2004 to November 2, 2004. Please amend the above-referenced application as follows:

Amendments to the claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.